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10/567,733	02/10/2006	438	2823	285995US26PCT		
RULE						
APPLICANTS Kohei Kawamura, Nirasaki-Shi, JAPAN; Yasuo Kobayashi, Nirasaki-Shi, JAPAN; Kenichi Nishizawa, Nirasaki-Shi, JAPAN; Yasuhiro Terai, Nirasaki-Shi, JAPAN; /K.P./ Akira Asano, Nirasaki-Shi, JAPAN;						
** CONTINUING DATA ***** This application is a 371 of PCT/JP04/10484 07/23/2004 /K.P./						
** FOREIGN APPLICATIONS ***** JAPAN 2003-293904 08/15/2003 /K.P./						
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/29/2006						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /KEVIN A PARENDO/ Acknowledged Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 9	TOTAL CLAIMS 17	INDEPENDENT CLAIMS 5
ADDRESS OBLON, SPIVAK, MCCLELLAND MAIER & NEUSTADT, P.C. 1940 DUKE STREET ALEXANDRIA, VA 22314 UNITED STATES						
TITLE Method for forming film, method for manufacturing semiconductor device, semiconductor device and substrate treatment system						
FILING FEE RECEIVED 1300	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		